

Direct-write laser-induced self-organization and metallization beyond the focal volume in tellurite glass

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We report on a self-organized process initiated on a potassium-tungsten-tellurite glass surface under repetitive femtosecond laser irradiation in a regime where cumulative effects lead to a localized melting. Specifically, we show that self-organized periodic patterns consisting of parallel nanoplanes perpendicular to the laser polarization are forming and extending beyond the zone under direct laser exposure. Examination of the modified regions revealed a phase change from a glassy tellurium-oxide to a crystalline tellurium. In addition, we observe that this self-organization process, associated with elemental redistribution and deoxygenation, is triggered by the optical-field strength. We suggest that early self-organized nanostructures formed by a local-field enhancement is subsequently reinforced by a metallization event in an open-air atmosphere.

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I. INTRODUCTION

Over the past decades, increasing research activities investigating the formation of periodic patterns on various surfaces exposed to intense picosecond and femtosecond laser beams were conducted. This research effort has recently been summarized by Bonse *et al.* [1]. Gratinglike patterns have been observed at the surfaces of various types of materials, such as metals, semiconductors, and dielectrics [1], suggesting the existence of generic mechanisms causing their formations. Due to their spatial micron to submicron periodicities, these nanostructures offer efficient means for controlling surface properties. For instance, one can use surface periodic patterns for tailoring wetting properties from hydrophilic to hydrophobic behavior, for encoding complex color interference-based patterns, or for modifying wear rate in tribological applications [2–4]. However, the formation mechanisms of these periodic surface nanostructures remain controversial [5]. Interference effects along with transient changes in the optical properties of the surface [6], second harmonic generation (SHG) [7–9], excitation of surface plasmon polaritons (SPPs) [10,11], or self-organization [12,13] are just a few examples of possible mechanisms that have been debated to explain these phenomena. In addition, chemical alterations such as a surface oxidation due to the irradiation in an air environment [14] and a phase transformation [15] were observed in the regime of periodic surface structures. In attempts to identify generic principles underlying the

formation of these nanostructures, previous studies explored the role of specific material properties such as viscosity [16], optical refractive index [17], band gap [7], and structural defects [18].

In this work, we investigate the formation of self-organized nanostructures on the surface of the tellurite glass resulting from a multipulse irradiation coming from a scanning femtosecond laser beam. In particular, we report on observations that challenge our current understanding of laser-induced nanogratings formation, and that highlight the complexity and diversity of phenomena underlying this self-organization process. The choice of the tellurite glass as a test material is motivated by its high technological relevance in a broad number of fields, and its metastable glass behavior that makes it easily prone to crystallization. Tellurium-based systems are subjected to a wide range of reversible and irreversible phase changes [19–22]. Especially, high refractive index and third-order nonlinear susceptibility, high dielectric constant, showing SHG, low glass transition and phonon energies are essential for technological applications such as all-optical switch, photonic diode, rewritable high-density storage media, and optical recording [19–30]. Among various TeO₂-based glasses, K₂O-WO₃-TeO₂ has a wide glass-forming region, and its properties have been studied well [23–26]. In this particular case, we demonstrate a self-organization phenomenon driven by local-field enhancement and controlled by the electric field that spans beyond the focal volume, and that leads to the formation of thin metallic surface accompanied by self-organized nanoplanes embedded in a dielectric matrix.

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II. EXPERIMENTAL PROCEDURES

A. Glass specimen preparation

The nominal composition of the glass used in this study is 10K₂O-10WO₃-80TeO₂ (mol %). Commercial powders of

reagent K_2CO_3 (99.5%), WO_3 (99%), and TeO_2 (99%) were mixed and melted in Au crucible at around 973 K for 30 min in an electric furnace. The melt was quenched onto a brass plate. After quenching, the specimen was crushed and remelted at 973 K for 30 min, which was followed by a subsequent annealing at 598 K for 1 h. The specimen was cut and polished prior to femtosecond laser exposure.

B. Femtosecond laser inscription

An Yb fiber-amplifier femtosecond laser (Yuzu from Amplitude Laser) emitting 270-fs pulses at 1030 nm was used in this experiment. Laser patterns were inscribed on the surface of potassium-tungsten tellurite glass as a line with a length of 10 mm. The specimen was translated under the laser focus with the help of a high-precision motorized stage (Ultra-HR from PI Micos). The laser beam was focused on the surface of the specimen with a 0.4 numerical aperture (NA) objective (OFR-20 \times -1064 nm from Thorlabs), resulting in a spot size (defined at $1/e^2$) of 1.94 μm (see Supplemental Material [31] for the laser spot size measurement). The transition from non-cumulative to a cumulative thermal regime exposure regime was determined by observing the evolution of the width of the laser-affected zone with the pulse repetition frequencies for a same net fluence and was found around 300–400 kHz. In what follows, the repetition rate was fixed at 1 MHz, which lies well within the cumulative regime for this particular glass. For comparative experiments between the two exposure regimes, 100-kHz-pulse repetition rate was used for representing the noncumulative thermal exposure regime. Pulse energy and translation velocity were selected as main variables to obtain different deposited energies. Accordingly, the deposited energy per unit surface (or “net fluence”) on the specimen can be approximated by

$$E_{\text{deposited}} = \frac{4E_p}{\pi\omega} \left(\frac{f}{v} \right), \quad (1)$$

where E_p is the pulse energy, ω is the optical beam waist (defined at $1/e^2$), f is the laser repetition rate, and v is the writing speed as described in Ref. [32]. This deposited energy is a dose of how much energy per unit surface is passing through the material but does not indicate how much of this energy is effectively absorbed. However, it remains a convenient and simple metric for comparing and reproducing experimental exposure conditions. Here, pulse-to-pulse overlapping ratios were varying from 95% to 99.9%, and the pulse energy was ranging from 1 to 200 nJ. Furthermore, tracks were inscribed using opposite directions of laser beam movement along a single writing axis and under three different linear polarization states (and therefore, orientation of the electrical field E) defined as parallel, at 45°, and perpendicular to the writing direction, respectively.

C. Specimen characterization

After laser exposure, specimens were first observed using an optical microscope (BX51 from Olympus), and subsequently coated with carbon thin film for high-resolution imaging and elemental analysis using a field-emission scanning electron microscope (FE-SEM, Gemini 2 from Zeiss)

equipped with energy-dispersive x-ray spectroscopy (EDS) operated at 20 kV. A cross-sectional milling and observations were performed in another scanning electron microscope combined with focused ion beam (SEM-FIB from FEI Nova 600 NanoLab). The milling was performed using a Ga-ion source operated at 30-kV acceleration voltage and 7-nA emission current. A Raman spectrometer (LabRam HR from Horiba) equipped with a 532-nm laser excitation source attenuated down to 4 mW (to prevent damaging the specimen) was used to record Raman spectra of the modified regions. The linearly polarized Raman laser beam was focused at the surface of the specimen using a 0.9 numerical aperture (NA) objective (100 \times -532 nm from Thorlabs). A series of line scans were performed at room temperature on each laser-modified region, from 10 μm outside the laser-written lines towards the center of the modification with a period of 1 μm , and with acquisition times of 30 s for each individual spot.

III. RESULTS AND DISCUSSION

A. Self-organized nanostructures beyond the focal volume

Figure 1 shows the laser-affected zones after irradiation with a pulse energy of 200 nJ and a pulse overlapping ratio of 99.5% at a pulse repetition rate of 1 MHz [Figs. 1(a)–1(g)] and 100 kHz [Fig. 1(h)]. At 1 MHz [Figs. 1(a)–1(g)], in the thermal cumulative regime, self-organized nanostructures, consisting of parallel planes oriented perpendicular to the laser electrical field orientation, significantly wider than the focal area of the laser beam formed at the tellurite glass surface are observed. This fact raises interesting questions concerning the underlying mechanism driving self-organization in this particular case. To date, the formation of nanogratings has been interpreted as a subtle interplay between the incoming intense laser field and the material under direct exposure. While such a mechanism may also be present here, it is not sufficient in itself to explain the full extent of the modification.

The modification exhibits two distinctive periodic arrangements: one, in the center, characterized by 800-nm spaced nanoplanes, and a second one, near the edges of the laser modified zone, consisting of 250-nm nanogratings with a much smaller span than the one found in the center. It is worth noticing that the secondary nanostructures found at the edges of laser-affected zones are best visible for a polarization perpendicular to the writing direction, and absent for a polarization aligned with the writing axis.

The electric-field strength appears to be an essential parameter for triggering or suppressing self-organized nanostructures at the focal area as evidenced by varying the pulse energies in Fig. 2. When multiple pulses accumulate at a fast enough rate, the temperature rise causes the material under exposure to melt locally [Fig. 2(a)]. The nanoplanes and the secondary nanostructures are forming at higher pulse energies, and consequently at higher temperatures. They are not found at lower pulse energies [Fig. 2(b)]. This sharp transition suggests the existence of a field-intensity threshold for triggering the self-organization process. In another research field exploring “electrocrystallization,” Luedtke *et al.* showed field-induced shape deformations in dielectric liquid

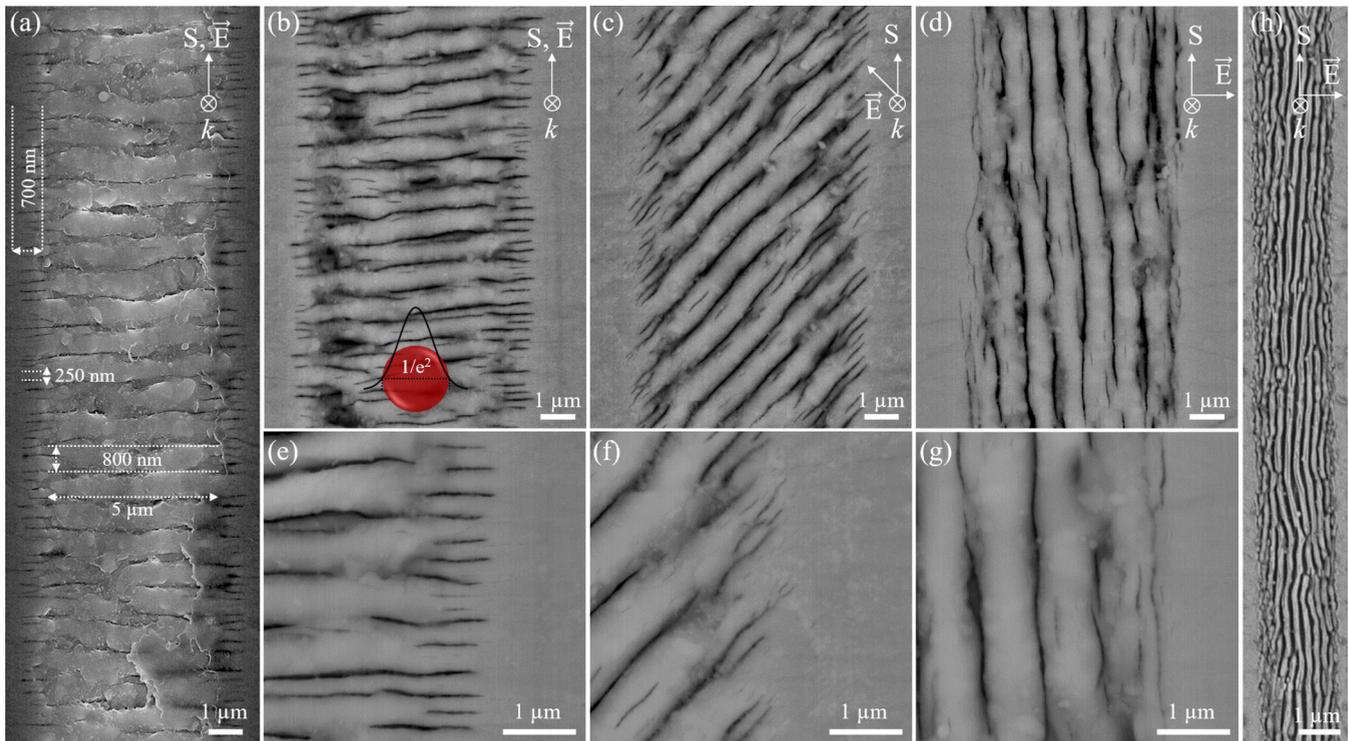


FIG. 1. Secondary electron (SE) and backscattered electron (BSE) images of potassium-tungsten tellurite surface after femtosecond laser irradiation at 1 MHz with different linear polarization orientations with respect to writing direction (as indicated with the electric field orientation): (a) secondary electron (SE) and (b) backscattered electron (BSE) images with longitudinal polarization, (c) 45° polarization and (d) transverse polarization. (e)–(g) Magnified BSE images of a boundary between the modified region and the parent material. The incoming pulse energy and writing speed were 200 nJ and 10 mm/s (incoming pulse fluence: 13 J/mm²), respectively. The red circle indicates the diameter of the laser spot. The laser modified zone containing nanostructures stretches significantly outside the zone that was under direct laser exposure. (h) SE image of potassium-tungsten tellurite surface after femtosecond laser irradiation at 100 kHz (200 nJ, 10 mm/s) for comparison. The width is measured as 1.8 μm in this noncumulative regime, which is in agreement with the measured optical beam diameter. The laser was propagating perpendicular to the image plane. The writing direction was from the bottom to the top of the image.

nanodroplets [33]. Similar to Fig. 2(c), at low electric field, field-induced shape change was observed. Further increase in the electric field resulted in a gradual enhancement of the molecular dipole reorientation. Although in Luedtke *et al.*, the electrical field is not produced by a laser, we note intriguing similarities.

In practice, the observable surface modification threshold is found for pulse energies of 10 nJ, while the nanostructure formation starts at 20 nJ and extends beyond 200 nJ, up to the point where ablation occurs. As a characteristic signature of a temperature-cumulative process, decreasing the translation velocity (i.e., increasing the pulse-to-pulse overlapping ratio) at fixed pulse energy leads to an increase of the modified area width. Likewise, at fixed translation velocity, increasing pulse energy causes a widening of the modified area up to 10 μm. The span of self-organized nanostructures changes accordingly with an exposure time and space and, remarkably, beyond the region under direct laser exposure.

Focused ion beam (FIB) milling was performed to observe the profile of these nanostructures and their extent within the material itself (Fig. 3). Unlike surface structures reported before that are in the scale of a few tens of nanometers, the depth of the nanostructures is in our case around 1 μm, and increases with increasing the pulse energy [34]. These observations show that higher fluence increase *both* lateral and

depth extensions of modified volumes. A fluence-dependent growth of the melt depth has been observed in photoexcited tellurium films [35,36].

B. Elemental analysis and bond characteristics

Energy dispersive spectroscopy (EDS) observations of laser modified zones in potassium-tungsten tellurite glass are shown in Fig. 4. Overall, small variations in the chemical composition have been observed as a consequence of laser modifications. The first nanostructures observed for a laser-pulse energy of 20 nJ are shown in Fig. 4(a). Nanoplanes show alternating tellurium (Te) and oxygen (O) contents, whereas the overall tungsten (W) content remains slightly higher. Figure 4(b) shows elemental distribution across a laser modified zone obtained with a pulse energy of 100 nJ. Similarly, alternating Te and O contents along nanoplanes were observed. Compared to the pristine material (dashed lines in Fig. 4), both modifications show approximately 3 wt.% higher Te, 4 wt.% lower O, and 1 wt.% higher W contents. Changes in chemical composition for tungsten, tellurium, and oxygen elements are also found beyond the nanoplanes. On the other hand, the content of potassium (K) atoms remains constant since it is the key modifier of the backbone tellurite glass structure. Experiments have shown that potassium is not sensitive to

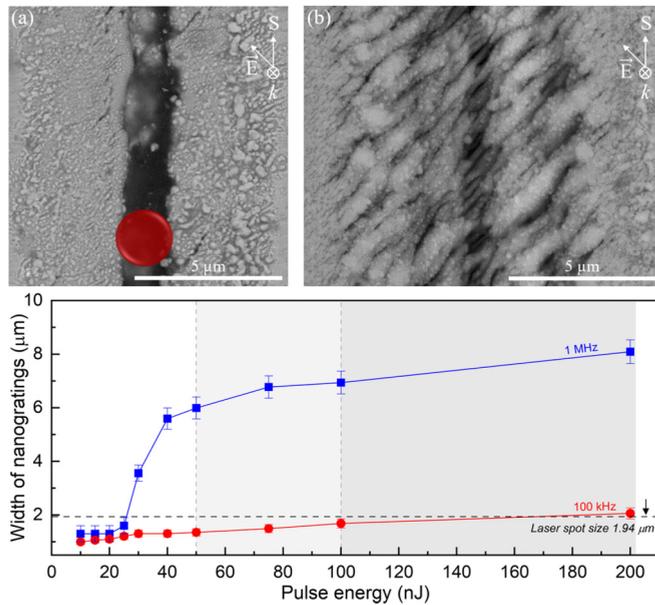


FIG. 2. Top: BSE images of potassium-tungsten tellurite glass surface after femtosecond laser irradiation with two different irradiation parameters: (a) 10 nJ, 0.5 mm/s (13 J/mm²); (b) 200 nJ, 0.5 mm/s (262 J/mm²), both obtained in the thermal cumulative regime. Bottom: plot of the width of the microstructures versus pulse energy at constant writing speed (0.5 mm/s). In the cumulative regime (blue curve at 1 MHz), a transition between two different modifications is observed. Below 30 nJ, a homogeneous molten region is found within the laser waist region. Above this value, self-organized structures consisting of parallel nanoplanes spaced by about 800 nm are present and gradually expand well beyond the zone under laser exposure. Both images correspond to 45° polarization (with respect to the writing direction). For comparison, the curve in red shows the width of the modified microstructures in the case of the noncumulative regime (red curve at 100 kHz). In the nonthermal cumulative process, the width remains within the range defined by the beam waist at the surface.

variations in local structures and, as such, the structure of potassium-tellurite (K₂O-TeO₂) glass has been preserved without any decomposition during heating and cooling cycles [37].

To investigate further the laser-induced modifications, we performed Raman spectroscopy measurements on various specimens. Figures 5 and 6 show the optical microscopy images of potassium-tungsten tellurite surfaces after femtosecond laser irradiation and the corresponding Raman spectra collected at points distributed across the laser modified zone with a spatial sampling period of 1 μm . The morphology of the line in Fig. 5 is similar to the one in Fig. 2(a). Gradual changes in the short-range order of the structure are observed along the scanned line as shown in Fig. 5(b). The spectrum at the beginning of the Raman scan (at $x = -10 \mu\text{m}$) is similar to the one of the pristine glass, shown in Fig. 5(c). The peak assignment, presented in Table I, was performed based on the work from Kosuge *et al.* [24]. The main peaks are found around 490, 610, 670, 720, 790, 860, and 920 cm^{-1} . Along the scanned line in Fig. 5(b), a few peaks with lower wave numbers start to appear three micrometers away from

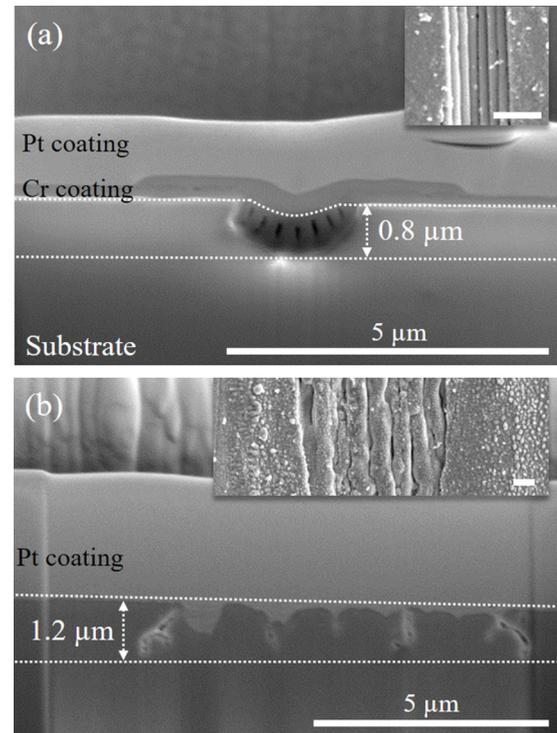


FIG. 3. SE images of FIB cut in potassium-tungsten tellurite glass: (a) 30 nJ, 100 mm/s (0.2 J/mm²) and (b) 100 nJ, 0.5 mm/s (131 J/mm² at 1 MHz), respectively. Both images correspond to a transverse polarization (with respect to the writing direction) and 1 MHz pulse repetition rate. Inset images show the modified zone before FIB process. The scale bars in both images are 1 μm .

the center ($x = 0 \mu\text{m}$). As their intensity gradually increases towards the center, the main peaks assigned to structures in the glass vanish in Fig. 5(c). Raman spectra are deconvoluted into Gaussian bands and accordingly, the peaks at 119, 139, 170, 220, 264, and 355 cm^{-1} are observed at the center of modified region (peak assignment is performed based on [38–45]). Peaks at 119, 139, 220, and 260 cm^{-1} belong to a crystallized trigonal tellurium (t-Te) phase. 170 cm^{-1} is attributed to Te-Te homopolar bonds in amorphous tellurium (a-Te). As reported by others, Te-Te homopolar bonds are not stable and crystallize above 285 K, however, they can be found up to 473 K [36,39,40]. This result indicates the existence of a chainlike structure within the amorphous phase after femtosecond pulses irradiation. In addition to the new peaks' appearance mentioned above, a weak peak at 360 cm^{-1} is found within the nanostructures. This peak is attributed to the bending vibration mode of W-O-W in WO₆ octahedra [44,45]. Note that the microstructure at 100 kHz in Fig. 1(h) shows no crystallization along the modified region [see Supplemental Material [31] for Raman spectra of the microstructure in Fig. 1(h)].

Figure 6 shows the relative intensities of the main peaks at various fluences. From outside of the modification to its boundary, Te-O bond concentration seems to decay in quantity. At the boundary of nanostructures, there is sharp increase in t-Te/glassy-TeO₂ ratio, followed by a decrease towards the center. There, the t-Te content decreases with laser

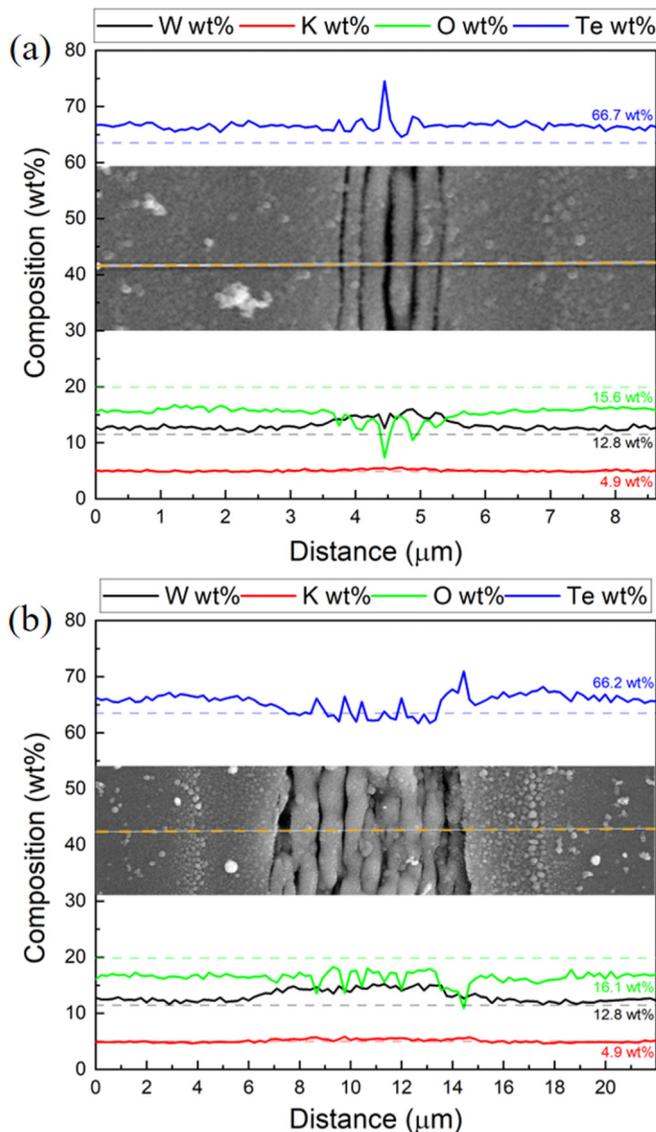


FIG. 4. Elemental distribution across a modified zone accompanied with SE images at 1 MHz: (a) 20 nJ, 0.5 mm/s (26 J/mm²); (b) 100 nJ, 0.5 mm/s (131 J/mm²). Colored values indicate the average composition along the scanned line. Dashed lines indicate the composition of pristine glass.

fluence and transforms to glassy TeO₂, the intensity of peaks related to TeO₃ + TeO₃₊₁ increases, and finally, TeO₄ trigonal bipyramids (tbp) decrease as reported for the tellurite glass with higher glass-modifier content [44].

Furthermore, the crystallization event expands beyond the focal volume and nanostructures, as in Fig. 6. At fixed translation velocities, an increase in pulse energy significantly affects the crystallization width. Above the nonlinear absorption threshold, the crystallized width increases approximately by 2 μm for every 10 nJ when the translation velocity is fixed to 0.5 mm/s. Likewise, at a fixed pulse energy, the translation velocity has a dominant effect on the crystallized region. In Fig. 6(c), self-organization is localized within 10 μm, whereas crystallized zone are found in a wider region (up to 40 μm). These observations are consistent with a temperature-driven process.

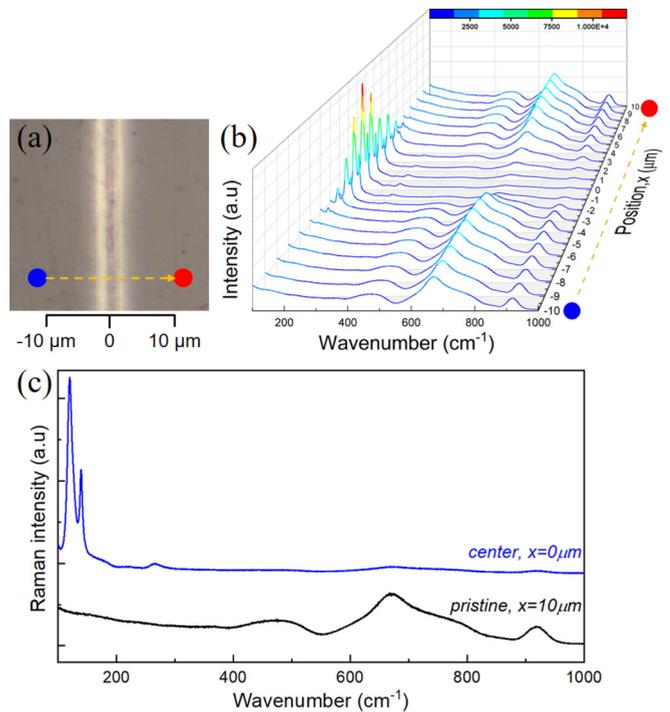


FIG. 5. Raman spectra of femtosecond laser inscribed lines. (a) Optical images of potassium-tungsten tellurite surface after femtosecond laser irradiation with laser parameters of 10 nJ, 0.5 mm/s (13 J/mm²). (b) Raman spectra collected by scanning laser across the modified zone and spectra collected at each 1 μm. Yellow dashed line indicates scanned line with Raman laser. (c) Raman spectra taken at the center of modification at $x = 0 \mu\text{m}$ and in an unmodified region at a position of $x = 10 \mu\text{m}$ away from the center.

Both Raman spectroscopy and EDS results of the self-organized nanostructures are consistent with one another. In brief, after the femtosecond laser irradiation, a cohort of tungsten atoms migrate to the vicinity of the nanostructures, whereas oxygen is removed along modified zones. A possible structural change is as follows. The lone electron pair in Te impedes the short-range atomic arrangement in TeO₂, making the first coordination sphere around Te highly asymmetric and variable. TeO₃ trigonal pyramids (tp) and TeO₃₊₁ distorted trigonal bipyramids (tbp) proportions are greatly reduced and change appreciably in the spatially confined medium, as Te becomes depleted by deoxygenation. In the meantime, tungsten coordination number might be altered, inducing change in the Raman peak-intensity ratio I₃₅₅/I₉₂₀. Previous study investigated the formation of a-Te from t-Te upon femtosecond laser irradiation [36]. In their observations, amorphization takes place after the first laser pulse, while crystallization occurs during subsequent pulses. Elemental dissociation of Te has also been reported for ZnTe [21,46]. In our case, as we observe the end product only, we do not know the transformation pathways starting from the initial tellurite glass that ultimately led to the formation of a-Te or t-Te phases as we are observing here. We can only speculate on a possible sequence of phase transformation. In such scenario, a-Te form during the first few laser pulses as a result of elemental redistribution and thermal melting, subsequently followed by recrystallization

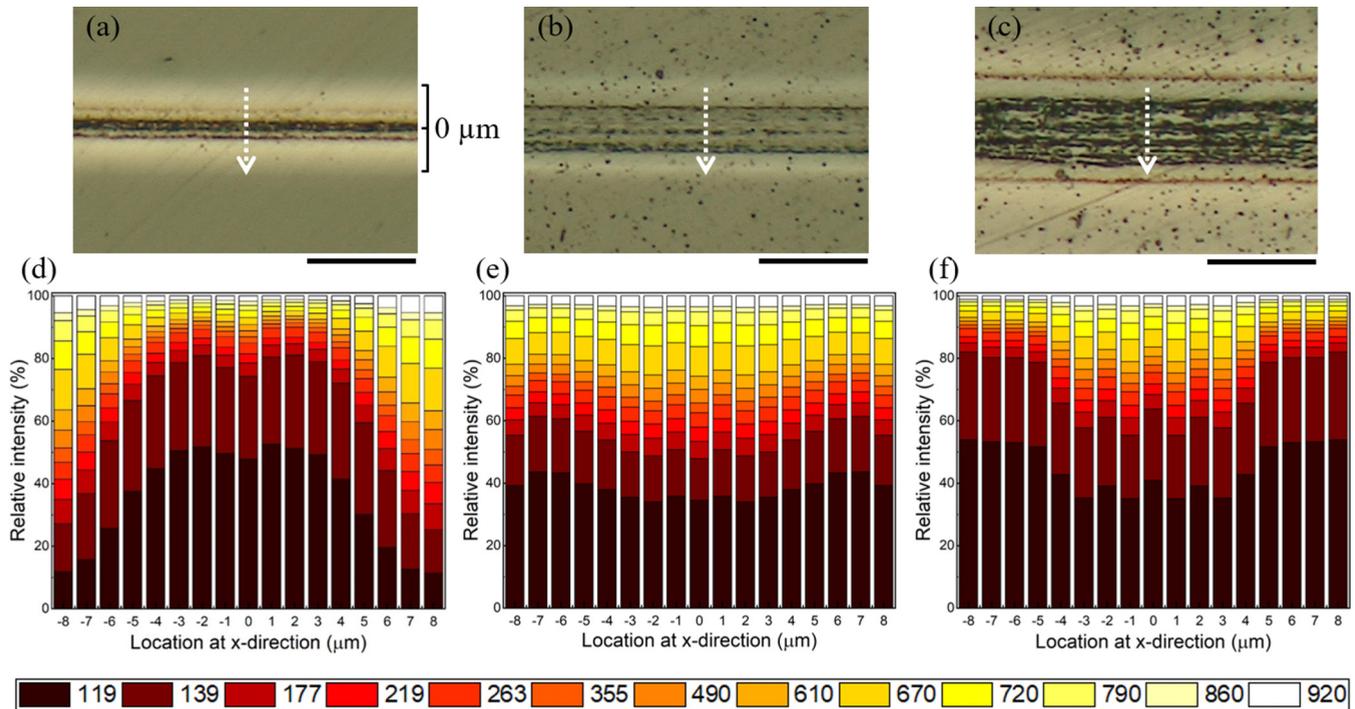


FIG. 6. Raman spectra of femtosecond laser inscribed lines. Optical microscopy images of potassium-tungsten tellurite surface after femtosecond laser irradiation at 1 MHz: (a) 20 nJ, 0.5 mm/s (26 J/mm²), (b) 200 nJ, 10 mm/s (13 J/mm²), and (c) 200 nJ, 0.5 mm/s (262 J/mm²). (d)–(f) Relative intensities of the main Raman spectra peaks found in modified zones (by scanning across the modified zone with 1 μ m of step size). White dashed lines indicate the Raman scanned lines and directions. The color-coded legend shows the main peaks and their assigned colors. Black scale bar is 20 μ m.

after further exposure. The observations of chainlike a-Te at 170 cm^{-1} in the Raman spectra support the formation of the amorphous phase. In addition, defective states in the tellurium created by deoxygenation may contribute to the formation of these chainlike structures at high temperatures. At lower pulse energy, the modified zone consists of a-Te and t-Te. At higher pulse energy, the final microstructure depends on the exposure dose (i.e., the number of cumulative pulses). For low-pulse overlapping ratio, only t-Te and a-Te are found after a few pulses' exposure. As pulses accumulate, the temperature becomes high enough over longer time to recrystallize immediately t-Te that had turned into an amorphous state. During this process, defects and dangling bonds of Te may react with neighboring oxygen molecules. This oxidation process in the nanostructured zone supports the following phase transformation sequence: t-Te \rightarrow a-Te \rightarrow glassy-TeO₂ [47]. Localized ionization of the ambient air due to the beam high-peak power ($\sim 10\text{--}30$ TW/cm²) [48] in the vicinity of the material surface is likely to further enhance this effect by feeding ionized oxygen atoms to the oxidation process. In parallel, the migration of tungsten elements contributes to preserving the glassy-TeO₂ along the nanoplanes.

Self-organized nanoplanes in the center of laser-affected zones and secondary nanogratings at the boundaries have notable differences in terms of structures highlighted in Figs. 5 and 6. Similar to Raman results, EDS shows slight differences in elemental content (Fig. 4). We attribute the formation of these secondary gratings to mechanical rupture and crack formation during solidification caused by a difference of thermal

expansion coefficient at the boundary between modified and unmodified materials. To support this observation, we note that since W⁶⁺ is a heavy metal ion, the depletion of W from the matrix in the nanogratings distorts the glass network and contributes to high stress levels at the phase boundaries, eventually leading to crack formation. The periodicity of these boundary nanocracks originates from the periodicity of the nanogratings phase itself. The fact that the periodicity of the secondary nanogratings does not change with laser fluence further supports that this process is of thermomechanical origin, and not an immediate outcome of laser exposure. Note that some of these nanocracks are also seldom present in the middle of the laser-affected zones, in-between nanoplanes (see Fig. 1 for a few examples), which is consequent with a fracture during solidification model, as proposed above. It also explains why fewer to none are found in the case of a polarization perpendicular to the writing direction as the nanoplane's vertical morphology leads to fewer stress-concentration points, prone to crack nucleation.

The fabrication of ultrathin crystalline tellurium films on the surface of TeO₂-based glass provides also a means for exploring how laser-induced geometric confinement in two dimensions can cause changes at the short- and medium-range structural order in a noncrystalline medium. Analyzing the Raman spectra, it is found that the structure of glassy-TeO₂ undergoes a dramatic modification. These results may enable direct-write tailored physical properties, e.g., the Te/TeO₂ interface has shown photoconduction in the UV region [49].

TABLE I. Peak assignments of Raman spectra of laser modified lines with references.

Wave number (cm^{-1})	Assignment
119	Symmetric stretching vibrations of crystalline Te (A1 mode)
139	Doubly degenerated vibration modes of crystalline Te (E_{TO} mode)
176	Te-Te homopolar bonds in amorphous Te
220	Doubly degenerated vibration modes of crystalline Te (E_{TO} mode)
260	Second-order E vibrational mode of crystalline Te
356	Bending vibrations of W-O-W in WO_6 octahedra
490	Symmetrical stretching vibration mode of Te-O-Te linkages
610	Vibration mode of continuous network composed of TeO_4 trigonal bipyramid (tbp)
670	Antisymmetric vibration mode of Te-O-Te linkages by two nonequivalent Te-O bonds in TeO_4 tbp
720	Stretching vibration mode between Te and nonbridging oxygen (NBO) of TeO_{3+1} (distorted tbp) polyhedra and TeO_3 trigonal pyramid (tp)
790	Te-O^- stretching vibration mode of TeO_{3+1} polyhedra
860	W-O stretching vibration mode in WO_4 or WO_6 units
920	Stretching vibration mode of the W-O^- and W=O terminal bonds associated with WO_4 or WO_6 polyhedra

C. Proposed scenario to explain the various phenomena

We propose the following interpretation that we illustrate schematically in Figs. 7 and 8.

Let us first examine the steps leading towards self-organized structures that span beyond the focal volume and examine the key events occurring during laser exposure according to our phenomenological model.

Step 1: During femtosecond laser inscription, multiphoton ionization seeds the first electrons that further lead, through avalanche ionization, to the buildup of an under-dense plasma. As bonds are broken within the main structural units of the glass, weakly bonded ions, such as O^{2-} and Te^{4+} form.

Step 2: The first few pulses create an electric-field enhancement through the formation of surface plasmon-polariton pairs (SPPs) that initiate the formation of self-organized nanostructures within the focal volume [50,51]. For specific conditions, surface electromagnetic waves (SEWs) through surface plasmon-polariton coupling (SPPs) can be excited. SPPs may originate from delocalized coherent electron density oscillations and propagate along the interfaces between the two different materials emerging locally during the self-organization process. Driven by the laser electromagnetic field, SPPs propagate and dissipate away from both sides of the laser-affected zone with a preferential direction defined

by the self-organized nanoplane orientation. For the excitation of SPPs, specific conditions for the dielectric permittivity of the involved media have to be fulfilled. Particularly, for an irradiation with ultrashort laser pulses, this excitation channel can be enabled even for semiconductors and dielectrics, as the initially nonplasmonic material can transiently be turned into a metallic state, enabling SPPs once a critical density of electrons in the conduction band is exceeded. The merge of SPPs leads to a spatial modulation of the local energy field distribution, which, through absorption mechanism, is imprinted in the specimen. Note that SPPs formation has been showed theoretically and experimentally on silicon upon femtosecond laser irradiation [52].

Step 3: As the pulses accumulate, thermal melting and elemental decomposition with deoxygenation events stimulate the crystallization of tellurium. As the molten state of modified tellurite glass includes charged entities (modifier cations, such as W^{6+} , and Te^{4+}) as well as neutral polar molecules such as TeO_2 , metallization occurs through intramolecular and intermolecular charge exchanges [53]. Under strong electrical field, the molten material becomes polarized and forms elongated clusters as a result of the balance between electrical forces on induced surface charges and interfacial tension forces. The retention of local electrical neutrality has structurally an effect on the connection and coordination of the polyhedra. As observed with the Raman spectra, migration of tungsten results in decrease of Te-O-Te linkages and W=O bonds and facilitates the formation of W-O-Te linkages, similar to WO_3 -rich tellurite glass [44]. Thus, the elemental redistribution is followed by deoxygenation and metallization process.

Step 4: As heat builds up locally, a thin layer of crystalline Te extends spatially. Here, we make the hypothesis that an evanescent SPP field propagates at the interface between crystalline tellurium and tellurite glass. As a dipole moment is created, forces between polarized particles arise and keep them apart. This mechanism would explain the periodicity of the nanostructures observed *outside* the zone under direct-laser exposure. To support this model, we note that similar ordering induced by an evanescent field has been observed in small dielectric particles where the periodicity depends on the particle diameters and the ionic polarizability that affects the repulsive and attractive potential between the charged particles [54]. Note that a plasmonic effect on interfacial energy transfer across the silicon-silicon oxide interface was showed by Derrien *et al.* [55].

Step 5: Depending on the pulse overlapping ratio, the temperature in the focal volume may stay high, long enough to allow for crystalline thin layers to grow. During cooling, due to the thermal expansion coefficients mismatch between modified and parent material phases, high-stress concentration builds up at the interface and causes the formation of interstitial microcracks localized in-between nanoplanes and, notably, where stress concentration occurs at the boundary between pristine and modified materials.

Let us now discuss the effect of field strength as observed in Fig. 8. Our interpretation is as follows. The laser intense electrical field determines the field-strength atoms are exposed. It will affect the condition for SPPs to exist [56] as it will impact the plasma electron density. In such model,

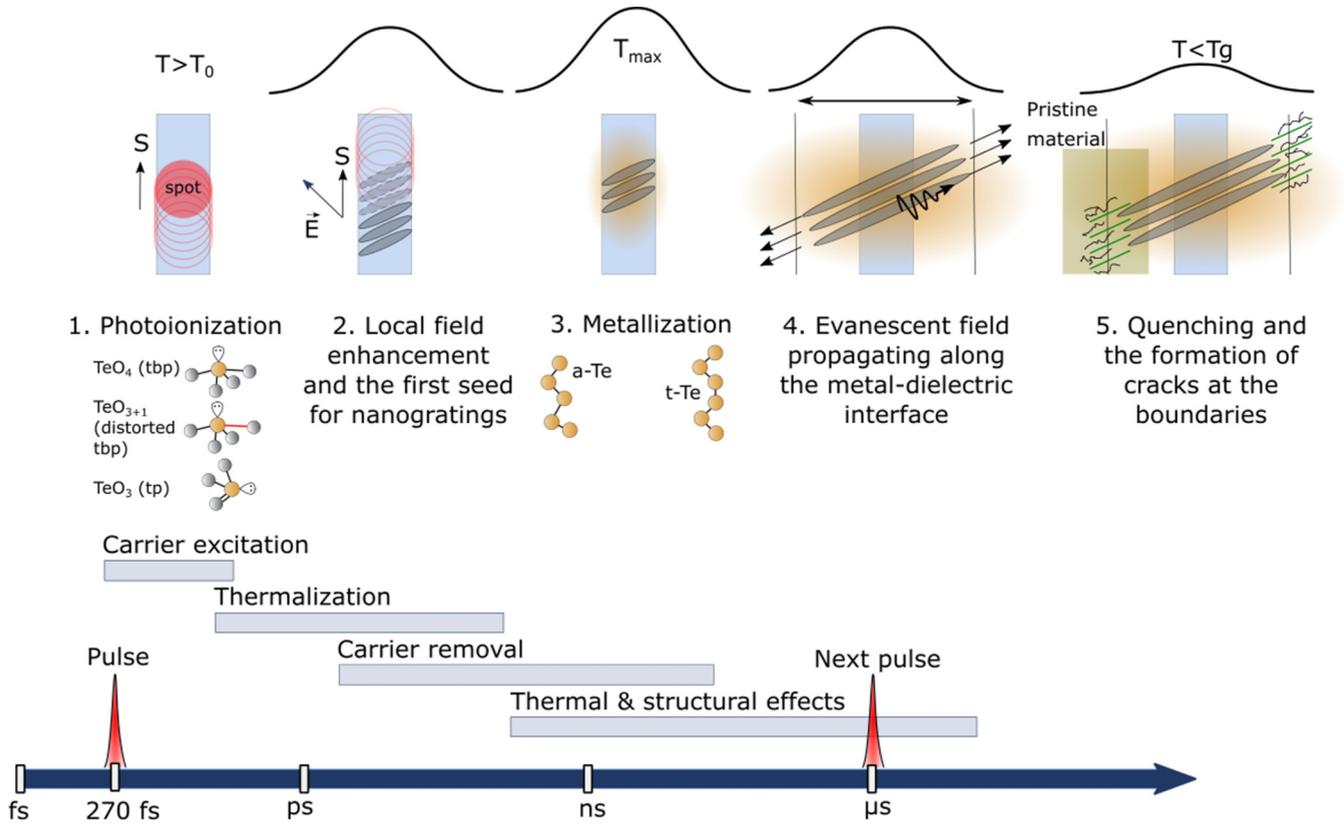


FIG. 7. Phenomenological interpretation for the sequential formation of self-organized nanostructures beyond the focal volume and its related metallization on ternary-tellurite glass surface: *Step 1*. Ionization through multiphoton absorption, step 2. Formation of nanogratings by local field enhancement after multipulse irradiation, step 3. Metallization by elemental decomposition and deoxygenation followed by thermal melting, step 4. Evanescent wave formation and SPP propagation at the metal-dielectric interface and finally, step 5. Ultrafast cooling and the formation of the cracks due to thermal expansion mismatch between modified and parent glass.

below a given threshold (here found around 20 nJ), the field intensity is not high enough to sustain the self-organization mechanism described before. Note that a similar mechanism

was proposed by Liao *et al.* [57]. In addition, the existence of uniform self-organized nanostructures at very high fluence is affected by the thickness of thin crystalline tellurium

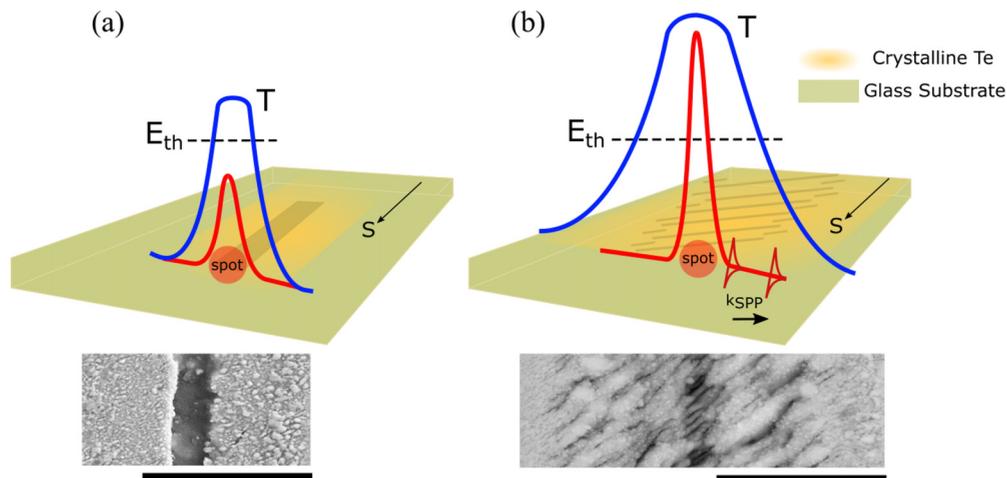


FIG. 8. Phenomenological interpretation of the wider nanostructure formation on potassium-tungsten tellurite glass. When multiple pulses accumulate, the temperature rise causes the material under exposure to melt. Despite the thermal-cumulative regime leading to the bulk heating of the material, nanostructures and secondary nanostructures form at higher pulse energy, but are not found for lower pulse energy. Temperature gradient indicated as blue and field strength illustrated as red line on modified zone (a) 10 nJ, 0.5 mm/s (13 J/mm²), (b) 200 nJ, 0.5 mm/s (262 J/mm²) (both at 1 MHz). The scale bars in both images are 5 μm.

film formed upon femtosecond laser irradiation. In the case of Figs. 8(a) and 8(b), the thicknesses of crystalline tellurium thin films are 4 and 60 nm, respectively. The thin-film thickness increases with laser fluence (2–60 nm, varying with the laser fluence). The optical penetration depth of tellurium is estimated to be 72 nm [58,59]. It has been showed that the ablation threshold of a transparent dielectric substrate coated with thin metallic or semiconducting films (with a thickness below an optical penetration depth) increases with increasing layer thickness due to the reduced coupling and transmission of the incident laser radiation through the layer to the substrate [59]. Although thin crystalline tellurium film formed upon femtosecond laser irradiation in our case, it enhances the stability of nanostructures at high fluence and increases of the ablation threshold of the tellurite glass substrate.

In summary, the dynamics of formation of this structure is complex. The structure under exposure is not static and evolves dynamically as the materials heat up and as nanostructures gradually form. Our interpretation is based on final state of matter, out of which we reconstruct a possible scenario. As “metallic seeds” form through elemental decomposition at high temperature, the main hypothesis is that they start promoting SPPs due at their interface when subsequent femtosecond laser pulse arrives. In this quasistatic evolution scenario, we assume that after each pulse, the system can be considered as a “metastable” configuration for the next incoming pulse, which supposes that viscosity remains sufficiently high, so that this approximation is valid, otherwise, the inhomogeneity (and phase separation) could not be maintained from pulse to pulse. From the material phase evidences collected, we observe the formation of crystalline tellurium surrounding the glassy phase itself localized within the nanoplanes. The growth of these nanoplanes outside the laser focus is explained by localized field enhancement. Here, we have considered the hypothetical presence of SPPs to explain the field enhancement that certainly also involves quasicylindrical waves that may play a constructive role in this field-enhancement mechanism, adding to the effect of the SPPs through cross-conversion mechanism [60]. To con-

firm this scenario, pump-probe experiments or alike could be considered for identifying the onset and sequence of intermediate events proposed here.

IV. CONCLUSIONS

We reported on a complex mechanism of self-organization induced by femtosecond lasers at the surface of potassium-tungsten tellurite glass. Specifically, we observed the formation of self-organized nanostructures oriented perpendicular to the laser polarization that span beyond the focal volume, and this in a regime where heat accumulates. Furthermore, our observations indicate a localized laser-induced metallization occurring under femtosecond laser irradiation and combined with a self-organization process. The formation of nanoplanes is accompanied by an elemental redistribution event that results in localized crystallization. These results are promising for nonlinear optics and photonic applications in which high refractive index, high polarizability, and dielectric constants play an important role. Adding the possibility of controlling the formation of crystalline tellurium phases in the dielectric matrix gives a further degree of freedom in the engineering of composite photonic structures, in particular, considering that tellurium has plasmoniclike properties.

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In this paper, G.T. wrote the draft paper, G.T. performed the most part of the experiments presented in this paper, T.K. did the first exposure lines and preliminary observation, G.T. and Y.B. interpreted the experimental results, and analyzed the experimental data. T.K. produced the bulk material and measurement data of various bulk properties. Y.B. designed and supervised the research. All the authors discussed and revised the paper.

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